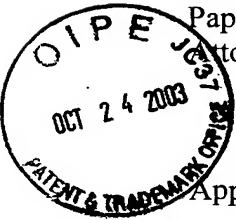


Application No. 10/603,433
Paper Dated October 22, 2003
Attorney Docket No. 116-031068



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/603,433
Applicant : HIROYOSHI KAZUMORI
Filed : June 25, 2003
Title : SCANNING ELECTRON MICROSCOPE AND METHOD
OF CONTROLLING SAME
Group Art Unit : 2881

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

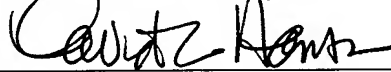
CLAIM FOR PRIORITY UNDER 35 U.S.C. § 119

Sir:

Applicant claims priority to Japanese Patent Application No. 2002-189936 which corresponds to the above-identified United States patent application and which was filed in the Japanese Patent Office on June 28, 2002. A certified copy of the priority document will follow. The priority benefits provided by Section 119 of the Patent Act of 1952 are claimed for the above application.

Respectfully submitted,

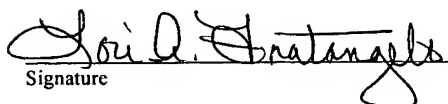
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I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on October 22, 2003.

Lori A. Fratangelo
(Name of Person Mailing Paper)


Signature

10/22/03
Date